

Application/Control No.	Applicant(s)/Patent under Reexamination
10/566,596	JARVINEN ET AL.
Examiner	Art Unit
LOIS ZHENG	1733

SEARCHED					
Class	Subclass	Date	Examiner		
75	343	5/17/2011	LLZ		
75	374	5/17/2011	LLZ		
75	375	5/17/2011	LLZ		
75	386	5/17/2011	LLZ		
75	369	5/17/2011	LLZ		
266	78	5/17/2011	LLZ		
266	90	5/17/2011	LLZ		
266	170	5/17/2011	LLZ		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
75	375	5/17/2011	LLZ		
75	386	5/17/2011	LLZ		
266	170	5/17/2011	LLZ		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
inventorship search	5/17/2011	LLZ		
Updated EAST search	5/17/2011	LLZ		